#### PATENT APPLICATION

HEWLETT-PACKARD COMPANY Intellectual Property Administration P. O. Box 27:400 Fort Collins, Colorado 80527-2400

ATTORNEY DOCKET NO. 10007457 -1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s):

Jeffrey S Obert et al

Confirmation No.: 9544

Application No.: 09/888975

Examiner: Ahmed, S.

Filing Date:

Jun 22, 2001

Group Art Unit: 1765

Title:

SLOTTED SUBSTRATE AND SLOTTING PROCESS

## COMMISSIONER FOR PATENTS Washington, D.C. 20231

## TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir	:	

Transmitted herewith is/are the following in the above-identified application.

Response/Amendment (X)

(x) Petition to extend time to respond

New fee as calculated below **(X)** 

Supplemental Declaration

No additional fee (Address envelope to "Box Non-Fee Amendments")

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11	TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$										

to Deposit Account 08-2025. At any time during the pendency of this 110 Charge \$ application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

(X) hereby certify that this paper is being transmitted to the Patent and Trademark Office facsimile

3/12/03 Number of pages: 8

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Patent

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Slotted Substrate And Slotting Process

Assistant Commissioner For Patents Washington DC 20231

### **AMENDMENT**

Sir:

In response to the action dated November 12, 2002, please amend the abovereferenced application as follows:

### IN THE CLAIMS:

Please amend claims 1, 11, and 24 as follows:

1. (Twice Amended) A method of manufacturing a slotted substrate comprising:

forming a masking layer over a front side of a substrate;

patterning and etching the masking layer to form a hole therethrough, wherein the hole exposes the substrate;

depositing a first layer over the masking layer and in the hole on the exposed substrate;

patterning and etching the first layer to form a plug in the hole; and

etching a back side of the substrate until a bottom surface of the plug is substantially exposed and a slot in the substrate is substantially formed, wherein the plug substantially plugs up the slot.